



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application Number : 10/811,152 Confirmation No. 8475  
Applicant : Ga Won LEE  
Filed : March 29, 2004  
Tech Cntr/AU : 2812  
Examiner : Lynne Ann Gurley  
Entitled : METHOD OF FORMING INTER-DIELECTRIC LAYER IN  
SEMICONDUCTOR DEVICE  
Attorney Reference : 123034-05004767  
Customer Number : 43569

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AFTER FINAL REJECTION**

Sir:

Responsive to the Office Action mailed July 31, 2006, Applicant herewith submits the following amendments and remarks.

Entered  
w/ RCE